Single-nanometer focusing of hard Xrays using adaptive optical system

Current status of X-ray mirror development for coming coherent-X-ray

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Background and today's contents

3rd generation SR facilities widely contribute to many S&T fields. 4th generation facility (XFEL) has already been here.

Highly brilliant X-ray is not particular, now.



How should mirror optic contribute to coherent X-ray optical system?

<u>Current research targets</u>

- 1. Focusing down to sub-10nm (including brief introduction of sub-50nm focusing)
- 2. Full-field, achromatic and high-resolution imaging of incoherent X-rays
- 3. Focused and full coherent X-ray illumination for diffraction microscopy

Required accuracy for nano-focusing under D-limited condition



Fabrication and figure testing technologies of Osaka University

⊘ Plasma CVM (chemical vaporization machining)
→ Rough figuring (Rapid figuring with 10nm (P-V) level accuracy)

- K. Yamamura et al., Rev. Sci. Instrum. 71 (2000), 4627
- © EEM (elastic emission machining)
 - \rightarrow Final figuring and smoothing (Fine figuring with atomically smoothing)
 - K. Yamauchi et al., Rev. Sci. Instrum. 73 (2002), 4028

Ø MSI (microstitching interferometry)
→ Figure tester with spatial resolution close to 0.01mm
K. Yamauchi et al., Rev. Sci. Instrum. 74 (2003), 2894

◎ RADSI (relative-angle determinable stitching interferometry)
→ Figure tester for steeply curved ellipse of large NA mirror
H. Mimura et al., Rev. Sci. Instrum. 76 (2005), 045102

JTEC URL http://www.j-tec.co.jp

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Typical deterministic figuring properties using EEM



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Sub-30nm focusing (2006)

Smallest size in hard-X-ray realized by total reflection achromatic mirror optics (focusing under diffraction limited condition)



Mimura et al., APL (2007)

<u>"Hard-X-ray sub-10nm focusing and</u> realization of high-resolution X-ray microscopy"



To realize Sub-10nm focusing K-B mirrors





<u>MSI with RADSI and EEM can prepare the</u> <u>surface figure with 1nm (P-V) accuracy.</u>

Estimation of required accuracy

@20keV Mirror length: 100mm, Focal length: 150mm



<u>Figure error of 1nm is not allowable</u>

Multi-layer technology is needed to realize large NA



Not only figure error but also thickness deviation of the multilayer induce wavefront phase error.

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At-wavelength phase-retrieval interferometry



New knife-edge method



Details of the new knife-edge method



30nm-focusing mirror was employed

for a demonstration of the proposed at-wavelength measurement



Performance of phase retrieval



Verification

To verify the reliability of the recovered phase error profile, we actually refigured the mirror by differential deposition method (G. Ice) using the recovered profile.



Focused beam profiles before and after DD



Comparison between the wave fields before and after phase compensation



On-line compensation of wavefront



Focusing mirror with phase error



Focusing mirror with phase error

Design concept



★ Glancing angle of compensator mirror is \mathbb{N} times smaller. (However, Consequently the length of the compensator becomes longer)

Required figure accuracy of the compensator mirror becomes \mathbb{N} times lower.

Phase compensator





Optical interferometer



Kimura et al., SPIE O&P (2008), Jpn. J. Appl. Phys (2009)





Sub-10nm focusing mirror



X-ray energy : 20 keV Mirror length : 80 mm Focal distance : 75 mm Glancing angle : 7.0 mrad Multilayer material : [Pt/C]₂₀ Substrate material : quartz glass

- Λ : d-space
- λ : X-ray wavelength
- n: Index
- θ : Glancing angle



EEM Machine



Micro- and RAD- Stitching Optical Interferometry



Laterally-Graded Multilayer Coater

Optical configuration for active phase compensation



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Sub-10nm focusing by using phase compensator





Maximum phase compensated here was λ/2. λ was 0.06 nm.

Beam waist structure

Nature Phys, (2010)



This is the smallest light beam human-made.



We tried to realize AKB mirrors having diffraction-limited performance.

1-dimentional Wolter mirror system

Magnification: 385x , Size of the point spread function: 43nm



Optical system of a one-dimensional Wolter optics



Magnified image



Spatial resolution test

Point spread function measurement





Evaluation of FOV



- To evaluate a field of view (FOV), we measured beam size on plane A by changing the glancing angle ($\Delta \theta$).
- This procedure is equivalent to shifting relevant points on the planes A and B.



•Very wide angular width (Δθ) of 122 μ rad was obtained. •It is equivalent to the FOV of 12 μ m.

Summary of AKB development



1-dimensional Wolter mirror demonstrated theoretically expected performances both in the resolution and FOV! Matsuyama et al., Optics Lett (2010)

AKB optics will be indispensable optics especially in coming XFEL experiment.

Focused x-ray illumination for diffraction microscopy



Set-up and samples



- **◆**X-ray energy: <u>12ke</u>V
- **Working distance:** 450mm
- ◆Camera length: 999mm
- ◆ CCD (Princeton Instruments PI-LCX:1300)

Pixel size: 20μm 1300 × 1340 pixels

Science 298, 2176 (2002) Shape-Controlle Synthesis of Gol an Silver Nanoparticles

Yugang Sun an Younan Xia*

Monodisperse samples o silver nanocubes were synthesized in large quantities by reducing silver nitrate with ethylene glycol in the presence o poly(vinyl pyrrolidone) (PVP). These cubes were single crystals and were characterized by a slightly truncated shape bounded by {100}, {110}, and {111} facets. The presence o PVP and its molar ratio (in terms o repeating unit) relative to silver nitrate both played important roles in determining the geometric shape and size o the product. The silver cubes could serve as sacrificial templates to generate single-crystalline nanoboxes o gold: hollow polyhedra bounded by six {100} and eight {111} facets. Controlling the size, shape, and structure o metal nanoparticles is technologically important because o the strong correlation between these parameters and optical, electrical, and catalytic properties.

SEM image







Exposure time : 800sec, 1.5x10¹¹ Photons to the cube

Y.Takahashi et al., Phys. Rev. B 80, 054103 (2009).

Summary

- Achromatic total-reflection mirrors realized sub-30nm focusing of hard X-rays.
- In-site wavefront correction are promising techniques to construct highly accurate optical system of hard X-rays.

- KB mirrors could reach sub-10nm focusing.
- AKB mirrors enable achromatic imaging of incoherent x-rays with sub-50nm-resolution.
- KB mirrors could condense x-rays with preserving coherency and could heighten the spatial resolution of diffraction microscopy up to sub-5nm.